## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Naoshige Itami et al.

Serial No.: 10/698,994

Conf. No.: 8859

Filed: October 31, 2003

For: METHOD OF MAN

METHOD OF MANUFACTURING A SUBSTRATE FOR AN LCD DEVICE

(as amended)

Art Unit: 2871 Examiner: Vu, Phu

## AMENDMENT AFTER NOTICE OF ALLOWANCE UNDER 37 C.F.R. 1.312

Mail Stop ISSUE FEE Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

Prior to issuance of the above-named allowed Application, please enter the

following amendments: